Dear researcher,

We hereby like to announce the 21st NNV-symposium on Plasma Physics and Radiation Technology, which will be held on the 3rd and 4th of March 2009 at the CongresHotel De Werelt in Lunteren. This symposium is intended for active scientists working in the field of Plasma Physics.

The symposium is sponsored by Stichting FOM, Nederlandse Natuurkundige Vereniging, TNO and Philips Lighting.

We welcome your participation. We also would like you to bring this symposium under the attention of your colleagues.
Language
English

Abstract submission deadline: January 30, 2009

Registration deadline: February 20, 2009

Conference date: 3rd and 4th of March 2009.

Place
The symposium will be held at CongresHotel De Werelt in Lunteren.

Payment
The cost of attendance of the symposium amounts to
€ 100 (one day, NNV-member),
€ 120 (one day, non-NNV-member)
€ 160 (two days, NNV member)
€ 200 (two days, non-NNV member).
The fee is to be paid by an invoice sent to you personally or to your institute/company after the meeting. Cash payment at the registration desk is not possible.

Program
The program will have a thematic approach. The program will be divided in 4 blocks. In each block the theme will be introduced by the session chair. Then, an internationally recognized expert will give an invited lecture, after which 3 Ph.D. students will give shorter lectures. There are two poster sessions. The student lectures will be selected from the submitted abstracts.

Participation
The meeting will be a two day session starting on Tuesday at 09.45 hrs and finishing on Wednesday at 17.00 hrs. Participations are asked to register before February 20, 2009. There are a limited number of rooms reserved, and we cannot guarantee that late registrations are accepted. Scientific contributions are welcome before January 30, 2009. If you are submitting a contribution please indicate your preference for an oral or poster presentation. The number of oral presentations that can be scheduled is limited, so not all requests for oral contributions will be granted.

If you plan to attend this symposium, please fill out the registration form and send it to K.C.A.Boom.v.d.Velde@tue.nl

Please, mention NNV-Lunteren in the subject header of your mail correspondence.

Hoping to hear from you soon.

The organizing committee,
Jaap Feijen  Philips Lighting
Ariël de Graaf  TNO Science & Industry
Gerard van Rooij  FOM-Institute ‘Rijnhuizen’
Jeroen Jonkers  Philips Research, Aken
Gerrit Kroesen  Eindhoven University of Technology
Edgar Vredenbregt  Eindhoven University of Technology
Terje Hansen  Eindhoven University of Technology
Rina Boom  Eindhoven University of Technology